

S/N 09/826,661

PATENT

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Yong-Jun Hu

Examiner: Joseph Nguyen

Serial No.: 09/826,661

Group Art Unit: 2815

Filed: April 5, 2001

Docket: 303.098US4

Title: LOW ANGLE, LOW ENERGY PHYSICAL VAPOR DEPOSITION OF ALLOYS

**PETITION FOR A ONE-MONTH EXTENSION OF TIME**

BOX AF  
Commissioner for Patents  
Washington, D.C. 20231

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AUG 29 2002  
TECHNOLOGY CENTER 3800

In accordance with the provisions of 37 C.F.R. § 1.136(a), it is respectfully requested that a one-month extension of time be granted in which to respond to the Final Rejection mailed April 24, 2002, said period of response being extended from July 24, 2002 to August 24, 2002.

Our check in the amount of \$110.00 is enclosed to cover the required extension fee.  
Please charge any additional fees or credit overpayment to Deposit Account No. 19-0743.

Respectfully submitted,

YONG-JUN HU

By his Representatives,

SCHWEGMAN, LUNDBERG, WOESSNER & KLUTH, P.A.  
P.O. Box 2938  
Minneapolis, MN 55402  
(612) 373-6971

Date 19 Aug 2002

By

J. Michael Anglin  
J. Michael Anglin  
Reg. No. 24,916

**CERTIFICATE UNDER 37 CFR 1.8:** The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: Attn: Box AF, Commissioner for Patents, Washington, D.C. 20231, on this 19th day of August, 2002.

Name

Amy Moriarty

Signature

Amy Moriarty

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